

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	6	((multiple or plural\$4 or third or three) near3 ((sens\$3 or detect\$3 or transducer) near3 package)) same (control\$3)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 09:50
L2	99	((multiple or plural\$4 or third or three) near3 ((sens\$3 or detect\$3 or transducer) near3 package)) same (control\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 09:50
L3	182	((plural\$4 or multiple) with (microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same accelerometer	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:05
L4	14136	((plural\$4 or multiple) with (microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same (control\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:13
L5	24592	accelerometer	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:10
L6	36	4 same 5	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:06

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L7	224	((plural\$4 or multiple) with (microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same (control\$3)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:48
L8	8681	accelerometer	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:10
L9	0	7 and 8	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:10
L10	7466	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer)	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:23
L11	2072	10 same (control\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:12
L12	313	11 and ((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same (control\$3)	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:13
L13	73	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:29
L14	16	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:47

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L15	3911	(multi\$1directional) or (multi near3 directional) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:50
L16	50558	((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3)))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 12:33
L17	5	15 same 16	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:49
L18	9144	(multi\$1directional) or (multi near3 directional) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:52
L19	568607	((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3)))	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:50
L21	2	((multi\$1directional) or (multi near3 directional)) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 10:53
L22	0	((multi\$1directional) or (multi near3 directional)) with (accelerometer or accelerat\$3 or sens\$3 or detect\$3 or transducer) with chip	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 10:56
L23	142	acceleration near3 module	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 11:04
L24	638	acceleration near3 module	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:04
L25	297	24 same control\$3	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:05

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L26	306	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3) with control\$3	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:39
L29	26	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3) with (ASIC or (integrated near3 circuit))	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:52
L30	0	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3) with (ASIC or (integrated near3 circuit))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 11:52
L31	1	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3) same (ASIC or (integrated near3 circuit))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 11:53
L32	61	(multi\$1axial or (multi near3 axi\$2) or ((three or third or tri) near3 axi\$2) or tri\$1axi\$2) with (accelerometer or accelerat\$3) same (ASIC or (integrated near3 circuit))	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 11:53
L33	2	((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same ((controller or control\$3 or ASIC or (specific near3 integrat\$3 near3 circuit)) with (exterior or ouside) with (housing or casing))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 12:36

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L34	447	((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same ((controller or control\$3 or ASIC or (specific near3 integrat\$3 near3 circuit)) with (exterior or ouside) with (housing or casing))	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 12:39
L35	0	34 same accelerometer	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 12:38
L36	1	34 and accelerometer	US-PGPUB; USPAT; USOCR	OR	ON	2006/03/05 12:38
L37	2	((microstructure or microsensor or micro\$1sensor or micro\$1electro\$1mechanical or microelectromechanical or micromechanical or micro\$1mechanical or electro\$1mechanical or electromechanical or MEMS or (micro near3 electro near3 mechanical) or (micro\$1machin\$3) or (micro near3 machin\$3))) same ((controller or control\$3 or ASIC or (specific near3 integrat\$3 near3 circuit)) with (exterior or ouside) with (housing or casing))	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/05 12:39